

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Akira FUKUNAGA et al. :
Serial No. NEW : **Attn: APPLICATION BRANCH**
Filed February 24, 2004 : Attorney Docket No. 2004-0173

PLATING APPARATUS AND METHOD OF :
MANAGING PLATING LIQUID COMPOSITION
(Rule 1.53(b) Divisional
of Serial No. 09/994,755,
Filed November 28, 2001)

THE COMMISSIONER IS AUTHORIZED
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CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
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Sir:

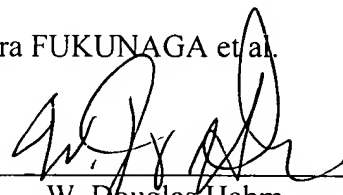
Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 2000-362559, filed November 29, 2000, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is of record in parent application Serial No. 09/994,755, filed November 28, 2001.

Respectfully submitted,

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